## **Microvia Drilling Technology**

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#### Introduction

The need for the high density provided by Build-up PWB installed in the mobile communication products requires the general trend towards a gradually smaller hole diameter.

For the micro via drilling, it has been categorized by the process as shown in Figure 1 so far, and due to the technology development, further smaller holes are processed. This paper presents these up-dated technologies.

#### CO<sub>2</sub> Laser

## Resin Direct Micro via Drilling by CO<sub>2</sub> Laser

Recent packaging board requires such micro vias with the diameter of Blind Hole:  $60-70 \,\mu m$  (2.4- 2.8 mil) and total drilled numbers of vias:  $400-500 \, k/$  board.

For this requirement, two beam  $CO_2$  Laser machines are utilized in the mass production. The machine is also equipped with 1,000 Hz Galvano scanner and the improvement of drilling condition; the drilling speed has almost doubled at 800-900 holes/ sec, compared with conventional method.

For the next generation of the packaging board, less than  $50\mu m$  micro via drilling is expected and it has been studied at R&D level for mass production application. (See Figure 2)

#### **Glass-reinforced Material**

Due to the cost and mechanical strength advantages, the utilization of glass-reinforced material (FR-4) becomes advantageous.

In order to keep the high beam energy at the circumference of the beam, the Laser beam mode is transferred into a "Top-hat" shape by optical method and it features and enables the conformable evaporation of both resin and glass at the inner wall of the hole, even whose evaporation temperatures are different. (See Figure 3)

Mass production example with diameter of 100- 125  $\mu$ m (4- 5 mil) at the speed of 400- 500 holes/sec is obtainable.

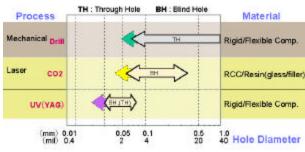
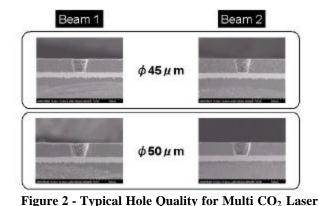


Figure 1 - Recent Technology Improvement for MicroVia



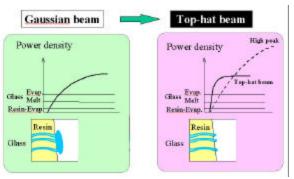


Figure3 - Improvement for Material with Glass

#### Cu (Copper foil) Direct Drilling

In the conformal mask method by using  $CO_2$  Laser, for the purpose of opening the window the coated copper foil is etched first, then the Laser drilling process follows. (See Figure 4.)

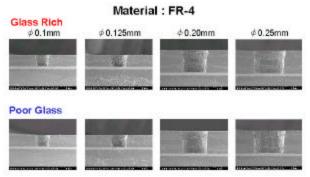


Figure 4 - Hole Geometry of CO<sub>2</sub> Laser

After four years of study, the actual production is now practiced with Cu Direct drilling, since the consistency of hole diameter, shape and quality becomes obtainable with various improvements such as the beam mode improvement of the Laser machine, the thin copper foil improvement by foil makers and effective surface treatment applied. (See Figure 5.)

## Material: Cu7µm, Multi Bond

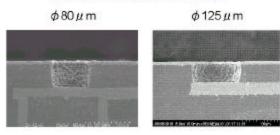


Figure 5 - Typical Hole Example for Cu Direct Drilling

This Cu Direct method makes it possible to drill even through holes of 100  $\mu$ m (4 mil) diameter at R&D level. (See Figure 6.)

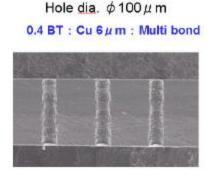


Figure 6 - Through Hole Example

### **UV Laser Drilling**

As mentioned previously, the further smaller micro via drilling is expected in near future for the next generation board, such a hole diameter as  $30-40 \,\mu$ m (1.2- 1.6 mil).

As this drilling range is below that of  $CO_2$  micro via drilling capability, the UV Laser application is anticipated.

At R&D level, the drilling of 20  $\mu$ m (0.8 mil) is practiced. (See Figures 7 and 8.)

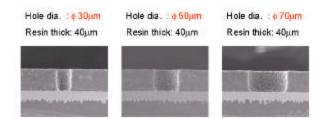
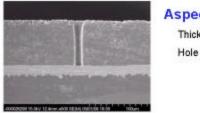


Figure 7 - UV Laser Drilling Example

# High Aspect Ratio Hole by UV



	Aspect Ratio :  ≡ 4				
ł.	Thickness	2	80µm		
L	Hole Dia.	ŧ,	20µm		
Ι.					

Figure 8 - UV Laser Drilling Example

#### Combination Drilling of UV and CO<sub>2</sub> Laser

For the blind via drilling with connection between first and third layers for the main board of base station, the combination drilling of UV and  $CO_2$  is utilized.

Surface copper foil is drilled by UV Laser, and then CO<sub>2</sub> Laser is applied for the similar manner as the conformal process.

The benefit of this method is the improved efficiency of  $CO_2$  Laser process when much of resin removal is required. (See Figures 9 and 10.)

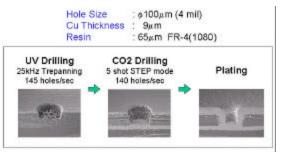


Figure 9 - Test Result, UV+CO<sub>2</sub> Laser Drilling

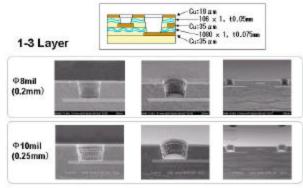


Figure 10 - UV+ CO<sub>2</sub> Laser Drilling

### **Mechanical Drilling**

The through hole drilling is widely made by the mechanical drilling machine, although the use of Laser drilling is studied in R&D level.

This through hole drilling requires smaller diameter than 0.1 mm (4 mil) for the next generation board, and the development is under way.

The maximum drill speed is 250 kmin-1 and the hole diameter of 50- 100  $\mu$ m (2- 4 mil) is obtainable. (See Figures 11 and 12.)

The hit rate of 500- 600 (hit/min) makes it possible for the productivity of 9,000- 10,000 (hole/ min/ machine) when the 6 spindle drilling machine is used with three high and a hole diameter of 100  $\mu$ m.

Drill Dia	φ0.10mm	¢0.085mm	¢0.075mm	φ0.050mm
0.4mm				
0.12mm		-11-	-11	0

Figure 11 - Micro Hole Drilling by 250kmin-1 Spindle

Panel	: t0.4mm(1 Cu5/5 // n	6 mil)BT n(0.2/0.2 mil), 1hig		
Spindle Spee				
Feed Rate				
Hole Pitch				
	: 200 hits/min			
Hole Wall Ro	ughness :	<10 µ m (0.4 mil)		
After 1000hits		After 2000hits		
non manhader a		Ser - Charles		

Figure 12 - Cross Section f0.050mm (f2mil)

### References

- 1. K. Matsumura, etc: Cu Direct Drilling Technology by CO2 Laser Proceedings of the 13th JIPC Annual Meeting, March, 1999, Tokyo.
- K. Arai: Trends of Laser Drilling Technology, Proceedings of the 14th JIPC Annual Meeting, March, 2000, Yokohama.